

# The Jyväskylä Accelerator Laboratory

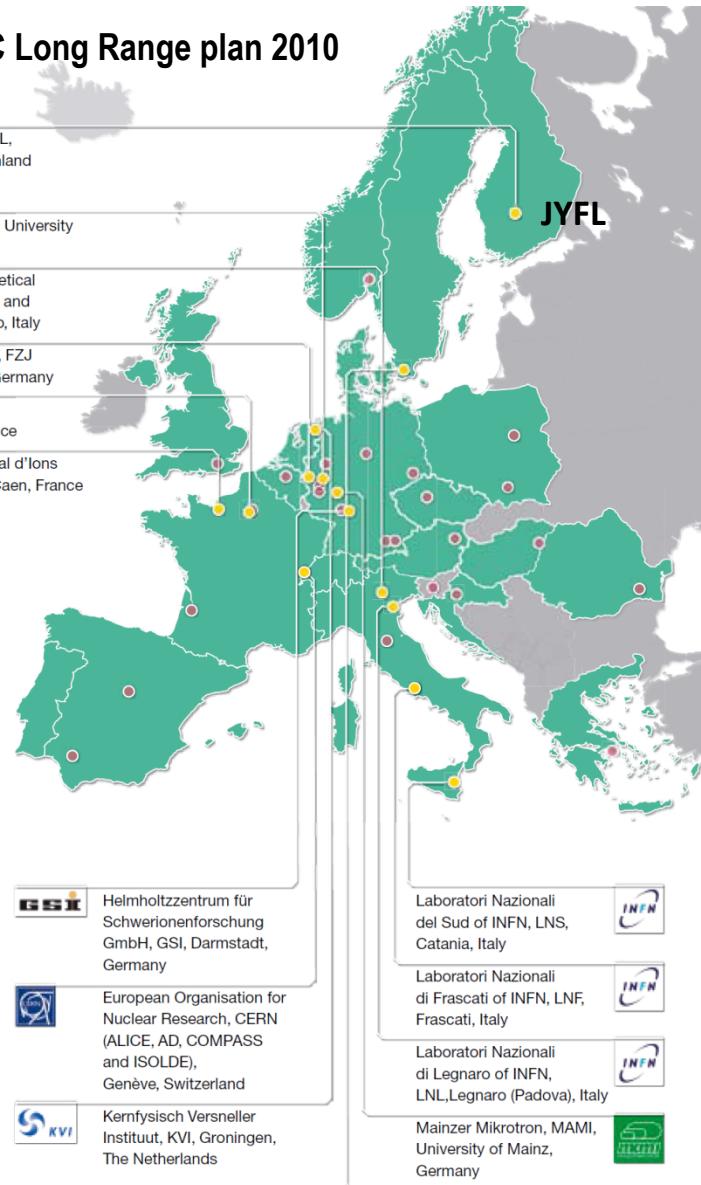
Pauli Heikkinen

JYFL

# Status

## NuPECC Long Range plan 2010

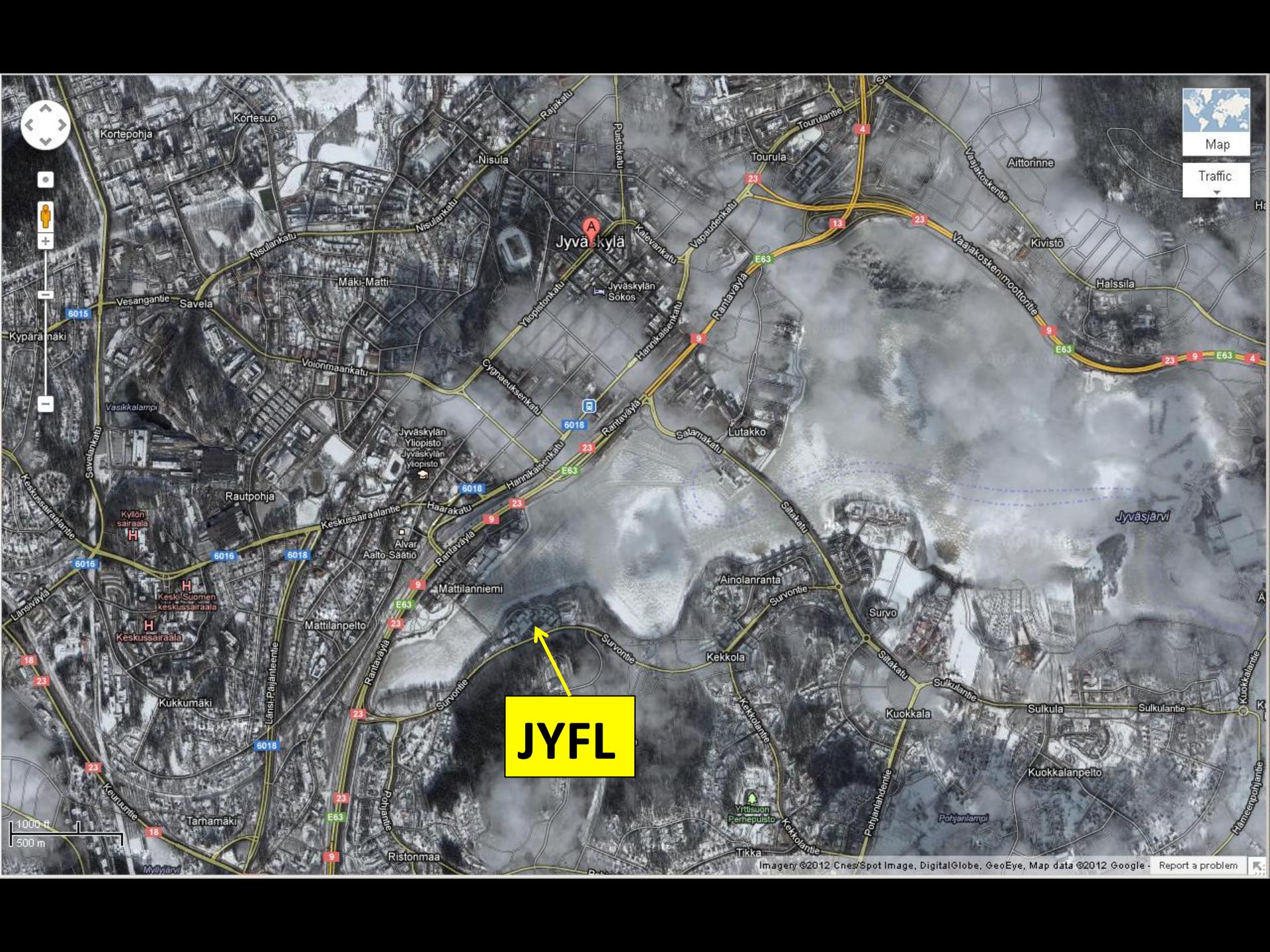
	Accelerator laboratory JYFL, University of Jyväskylä, Finland
	Electron accelerator ELSA, University of Bonn, Germany
	European Centre for Theoretical Studies in Nuclear Physics and Related Areas, ECT*, Trento, Italy
	Forschungszentrum Jülich, FZJ (COSY and HPC), Jülich, Germany
	Institut de Physique Nucléaire, IPNO, Orsay, France
	Grand Accélérateur National d'Ions Lourds, GANIL (SPIRAL), Caen, France



## JYFL Accelerator Laboratory

- Part of the Department of Physics
- Over 6000 beam time hours a year
- EU- Access Laboratory since FP4 - ENSAR in FP7
- Accredited European Space Agency (ESA) test facility
- International infrastructure in Finland
  - over 200 users a year, foreign investments of 10 M€

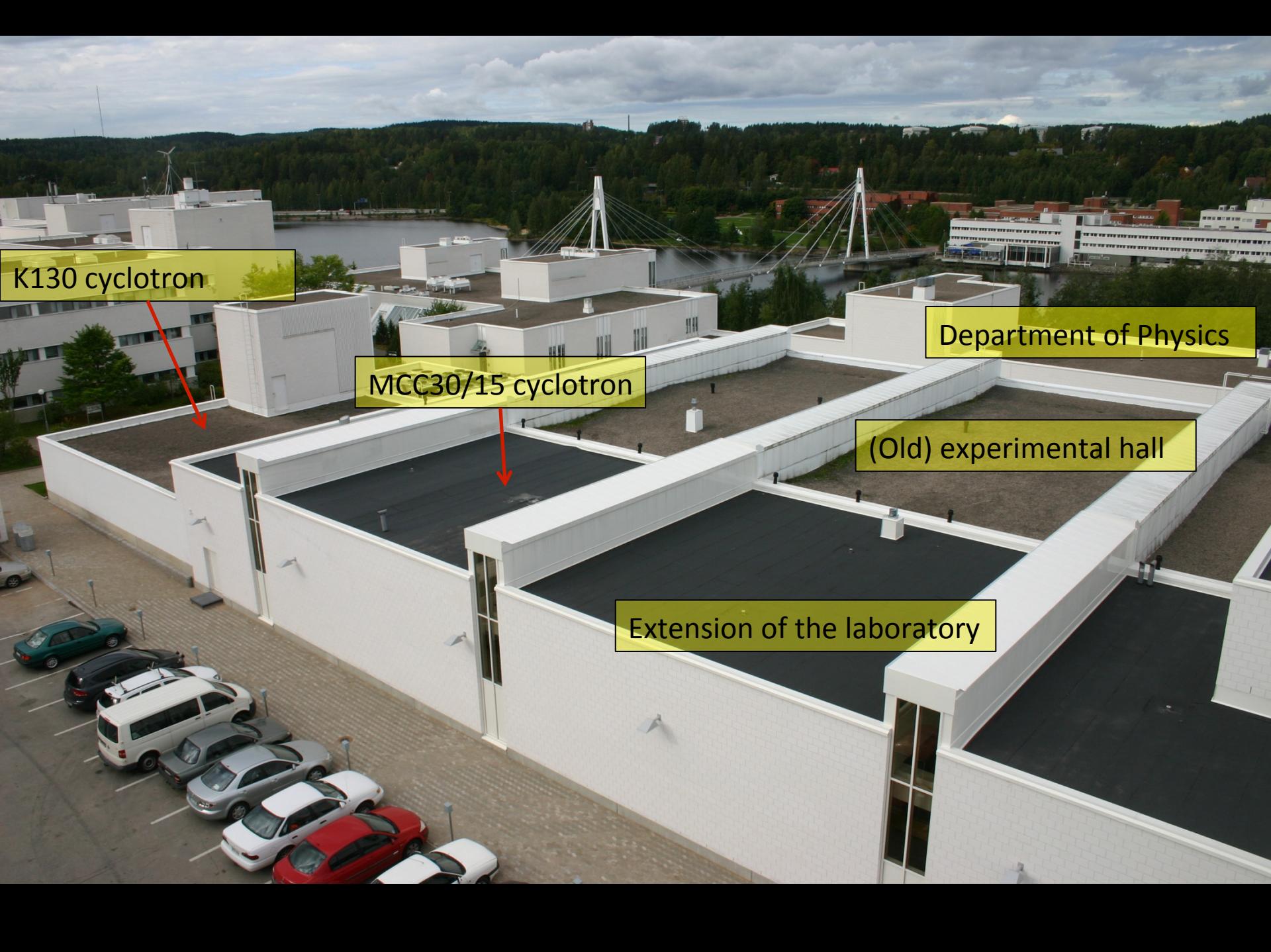
 NuPECC member countries  
 FP7 facilities  
 Smaller-scale facilities





2009 Google





K130 cyclotron

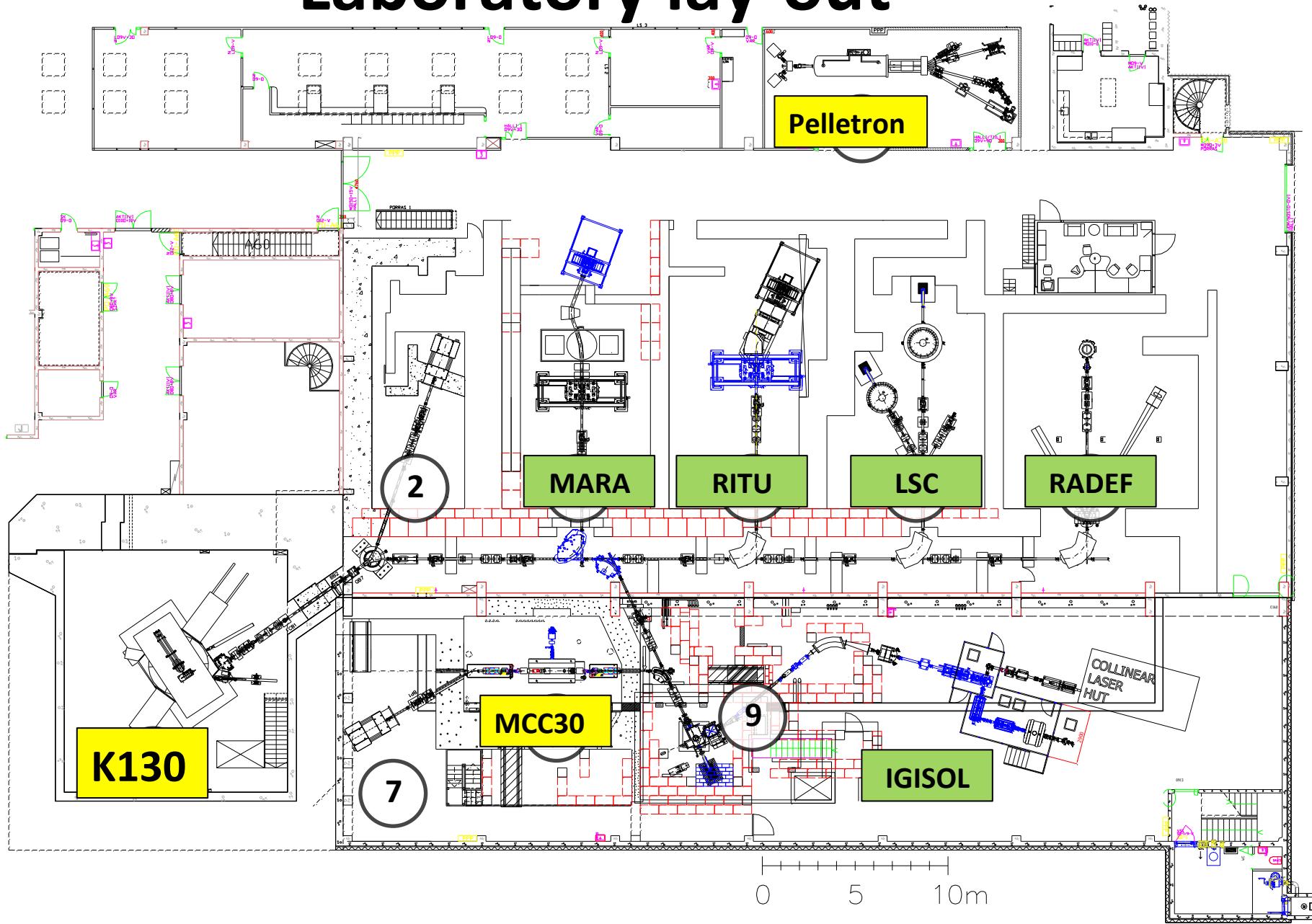
MCC30/15 cyclotron

Department of Physics

(Old) experimental hall

Extension of the laboratory

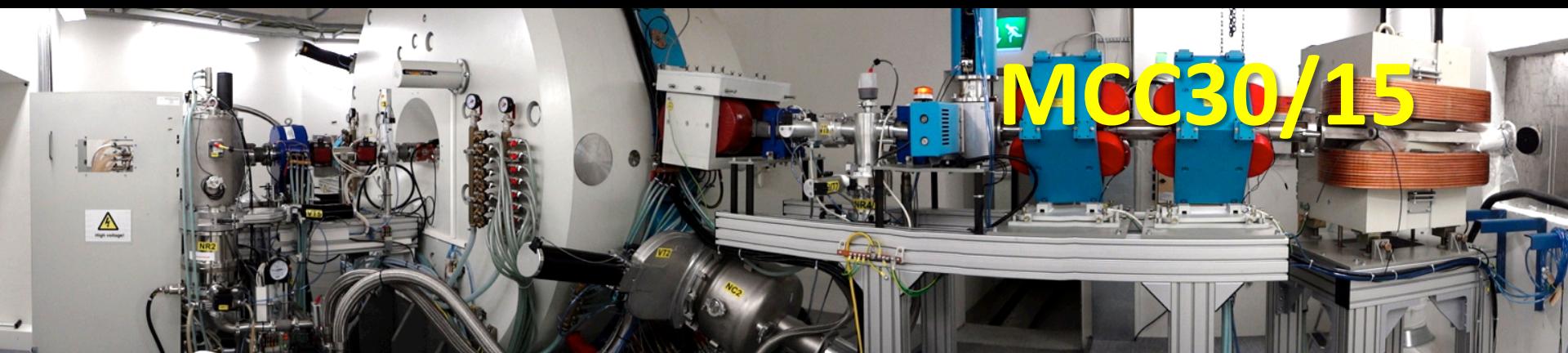
# Laboratory lay-out



K130



MCC30/15



Pelletron  
(1.7 MV)



# Electron Linac for radiation damage tests



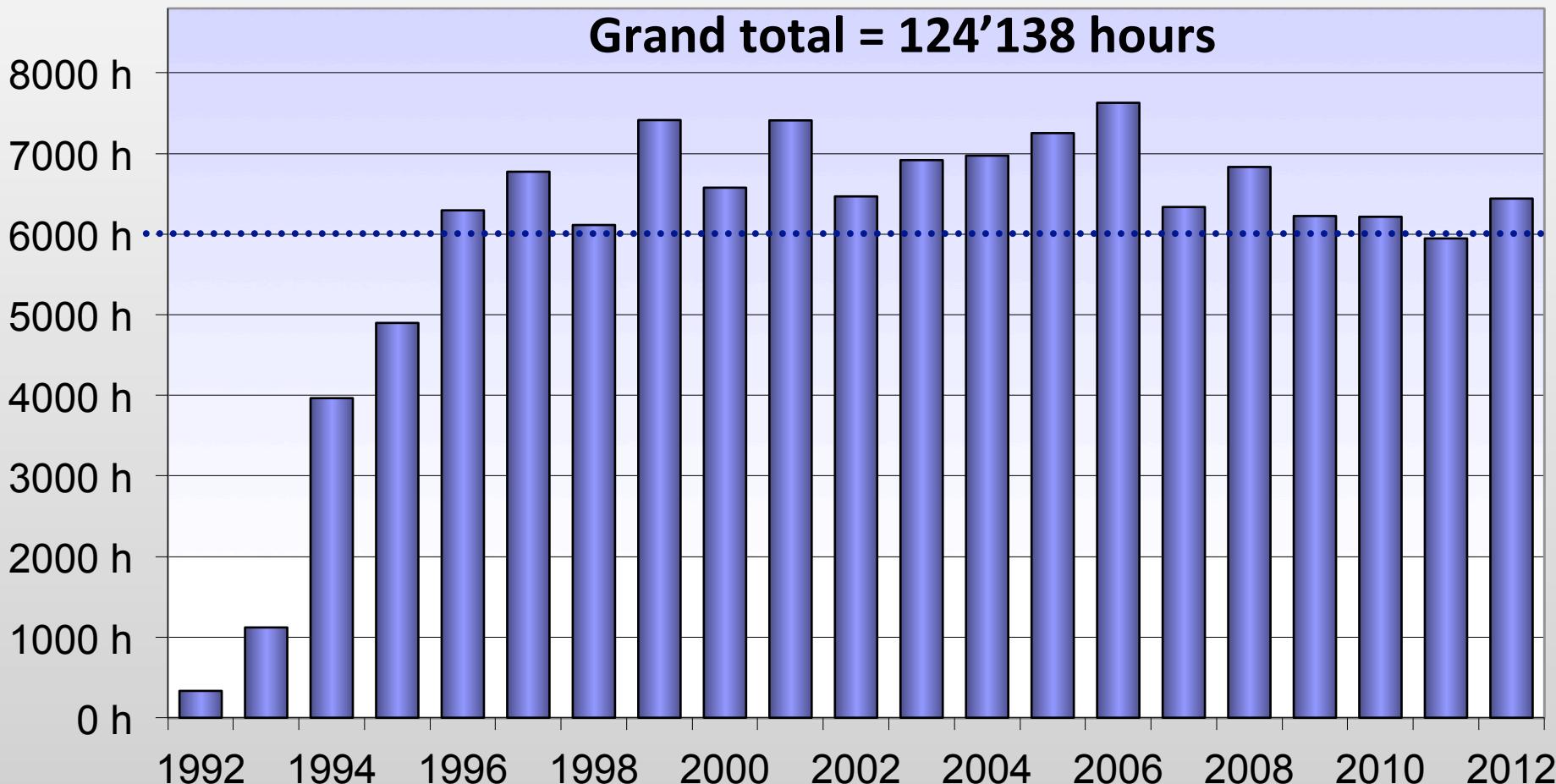
# K130 Cyclotron



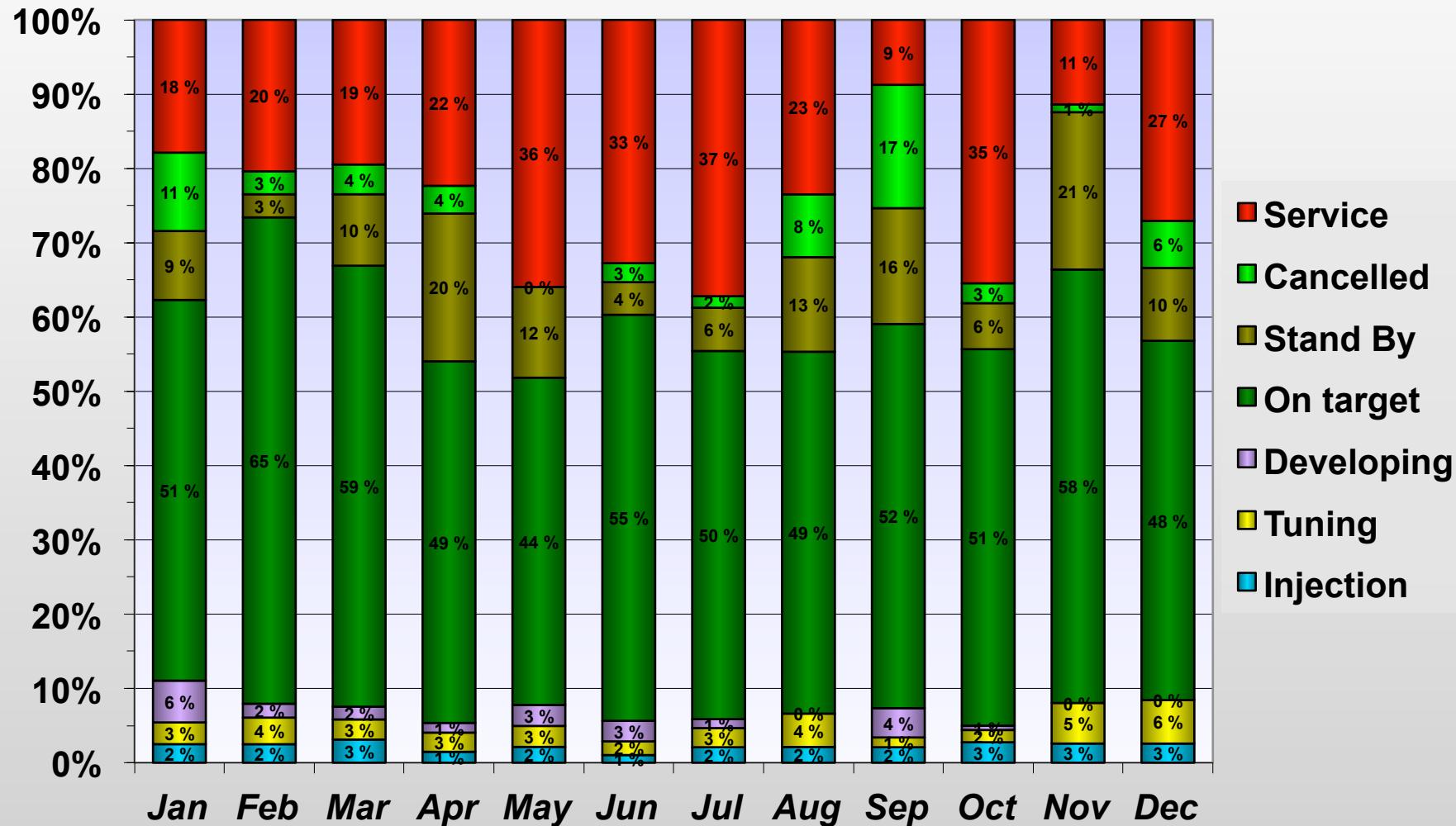


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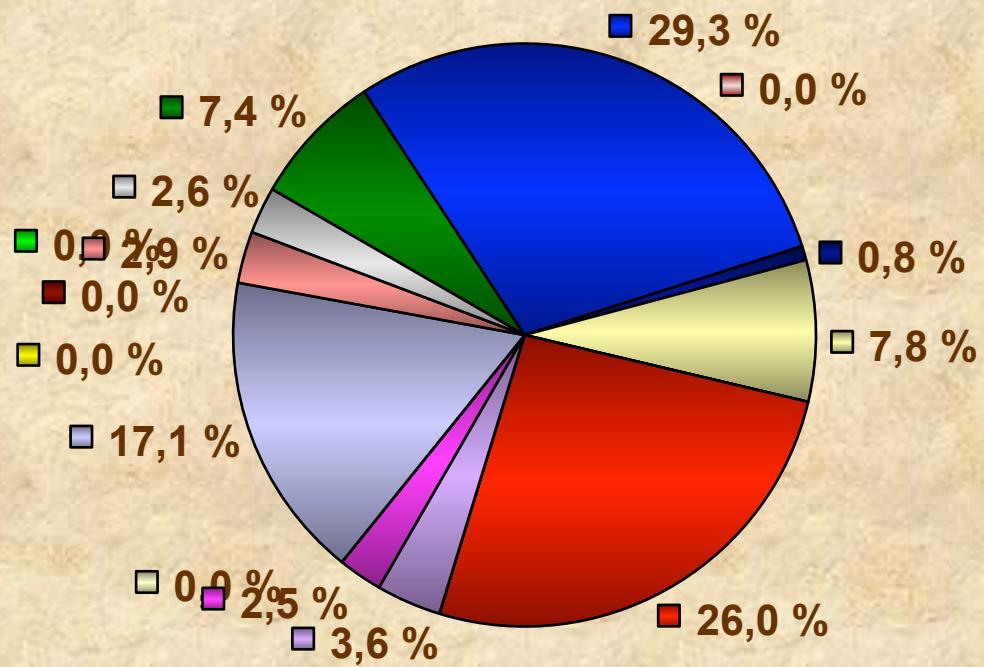
# Operation of the Jyväskylä Cyclotron



# *Monthly Use in 2012*



# *Beam Users in 2012 (Total Hours)*



- MAP
- IGISOL
- JUROGAM
- RITU
- LSC
- SMC
- RADEF
- HENDES
- APPLIED/T-LINE
- APPLIED/P-LINE
- APPLIED/A-LINE
- APPLIED/N-LINE
- SAGE
- OXYPHEN
- BEAM DEVELOPING

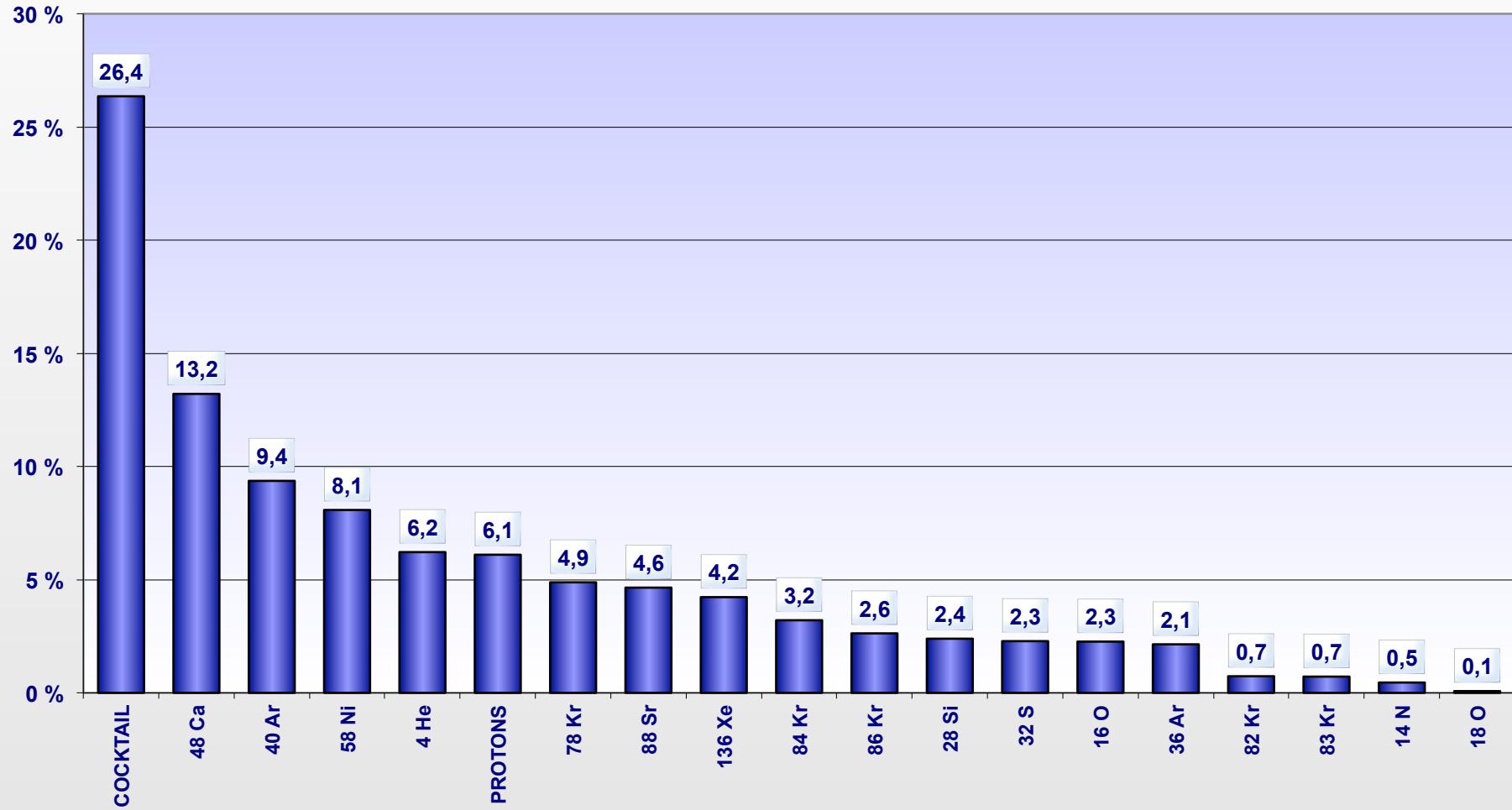


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## Accelerated Ions in 2012 (All)



Beam time



# K130 - Accelerated ions 1992 – 2013 (highest energy shown)

## 32 elements

**$^1\text{H}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
H -	62	62.1	
H +	80	80.0	Last used in 1995.
d -	55	27.5	
d +	65	32.5	

**$^2\text{He}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
3 He 2+	100	33.0	
4 He 2+	120	29.9	

**$^6\text{C}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
12 C 5+	240	19.9	
13 C 5+	250	19.2	

**$^7\text{N}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
14 N 6+	310	22.1	
15 N 4+	300	19.9	

**$^8\text{O}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
16 O 7+	330	20.6	
18 O 5+		10.3	

**$^9\text{F}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
19 F 4+	105	5.5	

**$^{10}\text{Ne}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
20 Ne 8+	400	19.9	
22 Ne 6+	223	10.1	

**$^{12}\text{Mg}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
26 Mg 6+	140	5.4	

**$^{13}\text{Al}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
27 Al 6+	133	4.9	

**$^{14}\text{Si}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
28 Si 9+	353	12.6	
30 Si 7+	148	4.9	

**$^{16}\text{S}$**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
32 S 9+	280	8.7	
33 S 5+	89	2.7	
34 S 7+	160	4.7	
36 S 8+	243	6.7	

**<sup>18</sup>Ar**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
36 Ar 9+	230	6.4	
40 Ar 12+	451	11.2	

**<sup>20</sup>Ca**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
40 Ca 9+	260	6.5	
42 Ca 9+	213	5.1	
44 Ca 9+	227	5.1	
48 Ca 10+	240	5.0	

**<sup>22</sup>Ti**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
46 Ti 9+	207	4.5	
47 Ti 9+	226	4.8	
48 Ti 11+	251	5.2	
49 Ti 10+	227	4.6	
50 Ti 11+	245	4.9	

**<sup>23</sup>V**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
51 V 10+	232	4.5	

**<sup>24</sup>Cr**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
52 Cr 10+	257	4.9	

**<sup>25</sup>Mn**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
55 Mn 12+	255	54.9	

**<sup>26</sup>Fe**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
54 Fe 12+	315	5.8	
56 Fe 11+	278	5.0	
56 Fe 15+		9.3	<i>Low intensity.</i>

**<sup>28</sup>Ni**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
58 Ni 12+	340	5.9	
60 Ni 13+	315	5.2	
61 Ni 13+	340	5.6	
64 Ni 14+	420	6.6	

**<sup>29</sup>Cu**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
63 Cu 13+	338	5.4	
65 Cu 15+	463	7.1	

**<sup>30</sup>Zn**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
64 Zn 14+	378	5.9	
66 Zn 13+	295	4.5	

**<sup>32</sup>Ge**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
72 Ge 12+	260	3.6	
74 Ge 13+	305	4.1	

**<sup>36</sup>Kr**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
78 Kr 17+	450	5.8	
82 Kr 16+	362	4.4	
82 Kr 22+		9.3	<i>Low intensity.</i>
83 Kr 16+	375	4.5	
84 Kr 20+	600	7.1	
84 Kr 22+	781	9.3	<i>Low intensity.</i>
86 Kr 20+	600	7.0	

**<sup>38</sup>Sr**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
84 Sr 16+	400	4.8	
86 Sr 17+	403	85.9	
88 Sr 16+	475	5.4	

**<sup>39</sup>Y**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
89 Y 23+	790	8.8	

**<sup>40</sup>Zr**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
90 Zr 17+	410	4.5	

**<sup>42</sup>Mo**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
98 Mo 19+	490	5.0	

**<sup>44</sup>Ru**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
102 Ru 19+	448	4.4	

**<sup>47</sup>Ag**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
107 Ag 21+	487	4.5	

**<sup>53</sup>I**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
127 I 23+	530	4.2	

**<sup>54</sup>Xe**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
128 Xe 23+	525	4.1	
129 Xe 25+	600	4.6	
129 Xe 37+		7.4	<i>Low intensity.</i>
130 Xe 23+	525	4.0	
131 Xe 27+	762	5.8	
131 Xe 35+		9.3	<i>Low intensity.</i>
132 Xe 22+	804	6.1	
136 Xe 30+	850	6.2	

**<sup>79</sup>Au**

<i>Ion</i>	<i>E (MeV)</i>	<i>E (MeV/u)</i>	<i>Comments</i>
197 Au 38+	974	4.9	

# 9.3 MeV/amu cocktails (M/Q≈3.7, ${}^{\ddagger}\!M/Q\approx3.3$ )

Ion	Energy [MeV]	$LET^{MEAS}$ @surface [MeV/mg/cm <sup>2</sup> ]	$LET^{MEAS}$ @Bragg peak [MeV/mg/cm <sup>2</sup> ]	$LET^{SRIM}$ @surface [MeV/mg/cm <sup>2</sup> ]	$Range^{SRIM}$ [microns]	$LET^{SRIM}$ @Bragg peak [MeV/mg/cm <sup>2</sup> ]
<sup>15</sup> N <sup>+4</sup>	139	1.87	5.92 (@191 um)	1.83	202	5.9 (@198 um)
<sup>20</sup> Ne <sup>+6‡</sup>	186	3.68	9.41 (@138 um)	3.63	146	9.0 (@139 um)
<sup>30</sup> Si <sup>+8</sup>	278	6.74	13.7 (@114 um)	6.40	130	14.0 (@120 um)
<sup>40</sup> Ar <sup>+12‡</sup>	372	10.08	18.9 (@100 um)	10.2	118	19.6 (@105 um)
<sup>56</sup> Fe <sup>+15</sup>	523	18.84	29.7 (@75 um)	18.5	97	29.3 (@77 um)
<sup>82</sup> Kr <sup>+22</sup>	768	30.44	41.7 (@68 um)	32.2	94	41.0 (@69 um)
<sup>131</sup> Xe <sup>+35</sup>	1217	54.95	67.9 (@57 um)	60.0*	89*	69.2 (@48 um)

\*Estimated values for 1.22GeV Xenon in Silicon

# Towards(/back to) high intensities

1. Improve transmission from the ion source to the cyclotron
2. Improve the extraction efficiency from the cyclotron
  - Reason to decreased extraction efficiency was mainly ripple in RF voltage due to faulty electronics in phase control
    - Mainly solved
3. New 18 GHz RT/SC-ECRIS (plan)
  - New design based on MSU SUSI field configuration

# Solutions to improve the transmission

- Two different upgrades are proposed:

A)

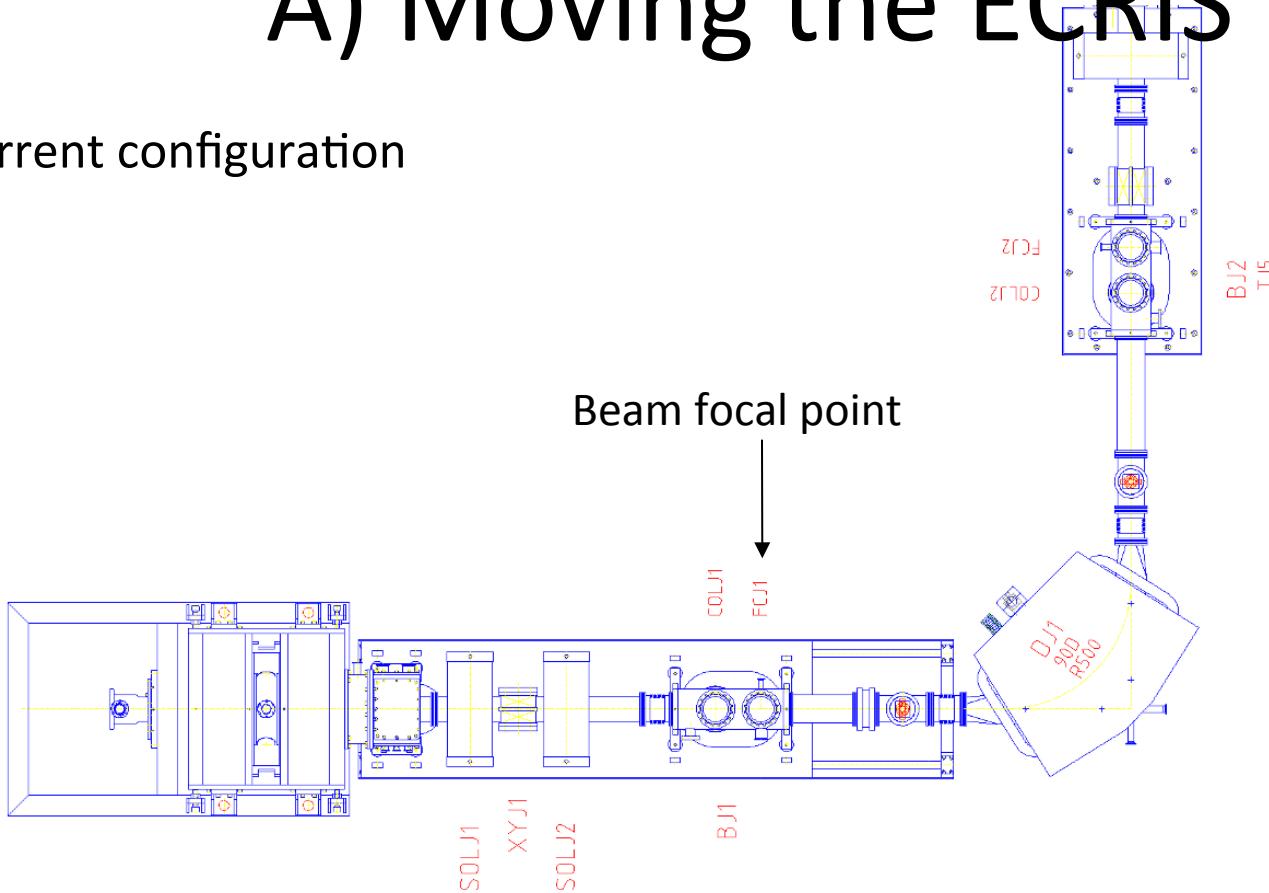
Minimization of the high space charge section by moving the ECRIS close to the dipole

B)

Increasing the beam energy in the high space charge section by HV biasing this part of the beam line (increasing the ECRIS extraction voltage)

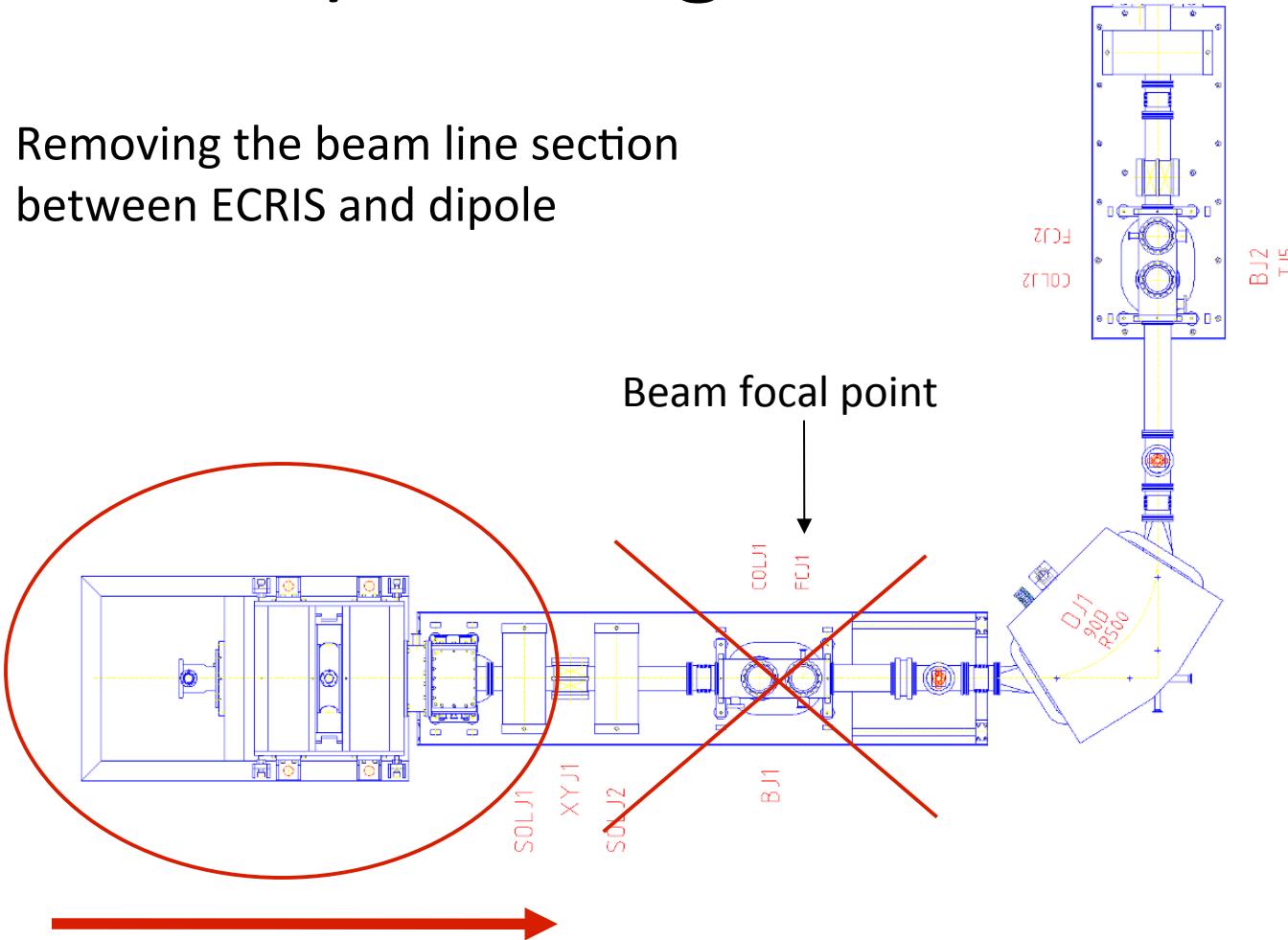
# A) Moving the ECRIS

Current configuration

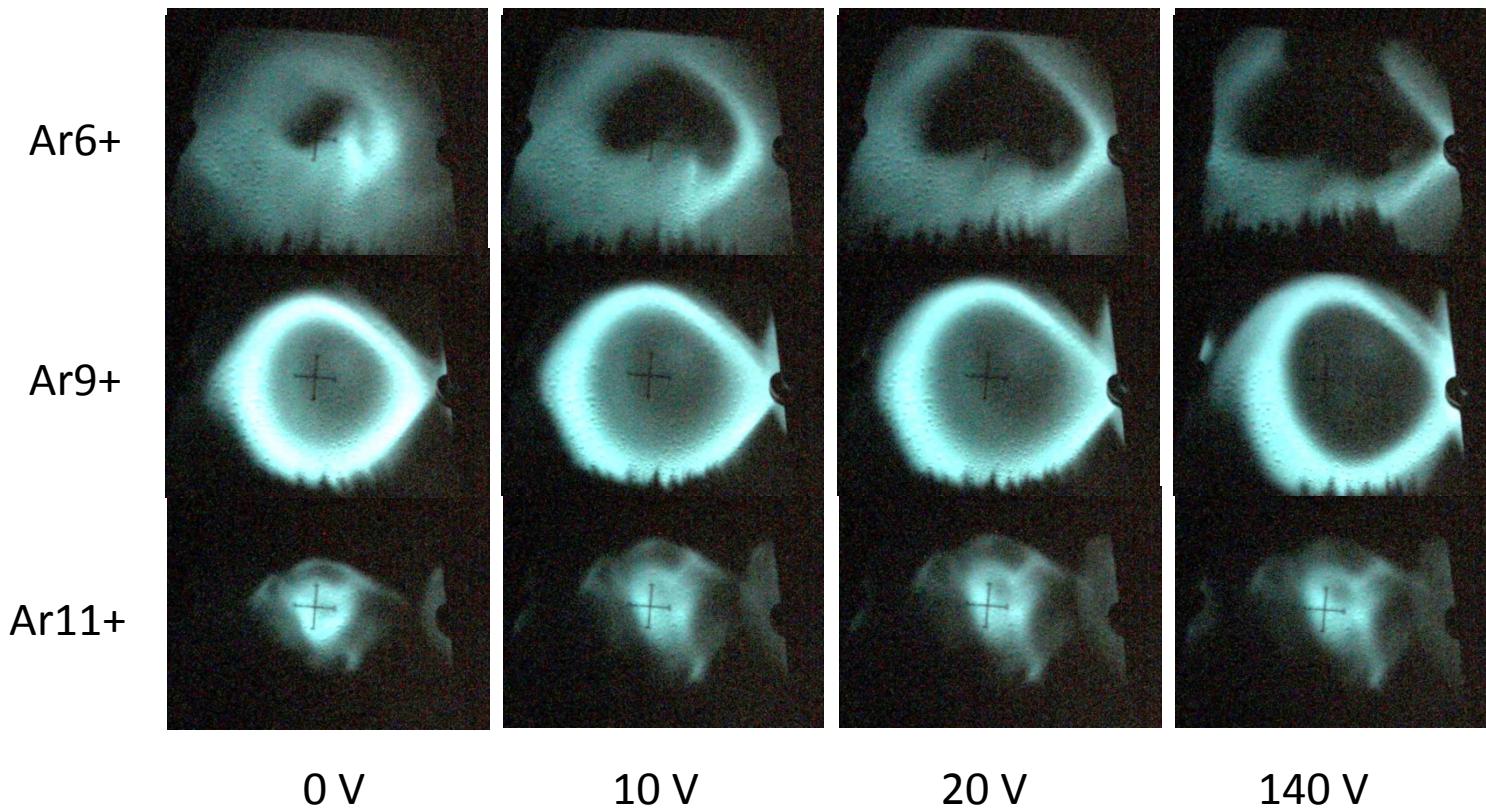


# A) Moving the ECRIS

Removing the beam line section  
between ECRIS and dipole



# Effect of removing electrons – beam profile



Hollowness caused by magnetic focusing induced ion species interactions (multiple focal points, “beam-inside-beam”)

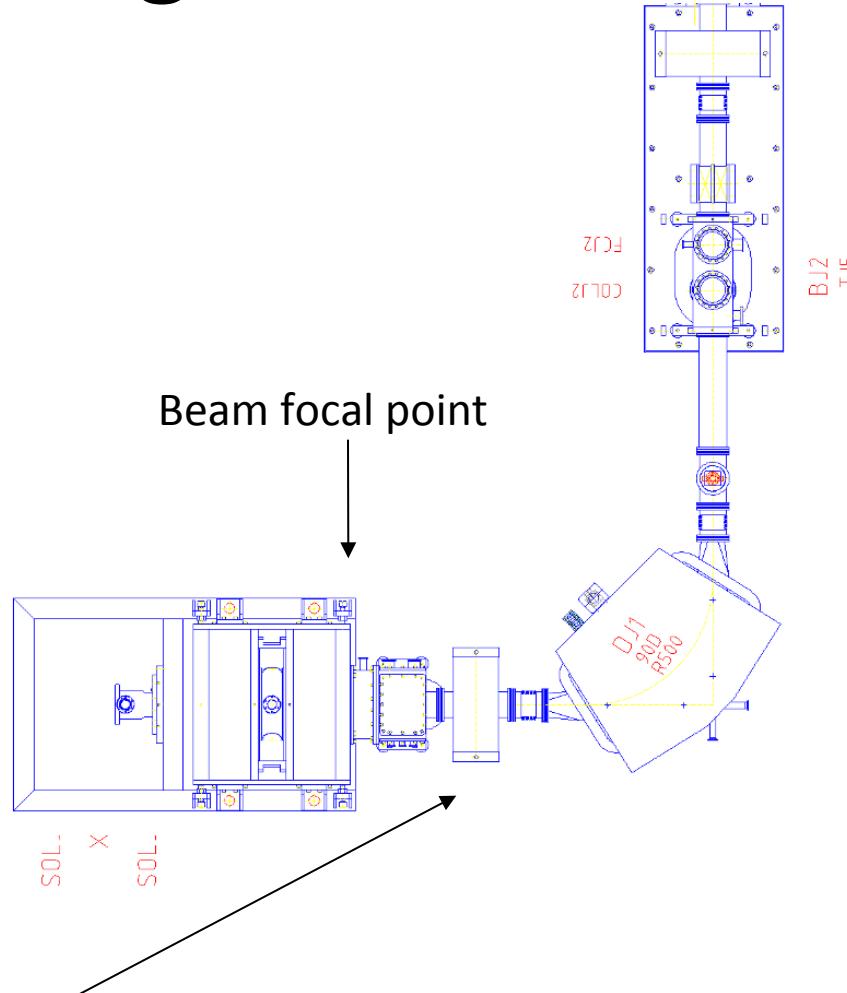
Space charge affects also non-hollow beams (e.g. Ar11+)

# A) Moving the ECRIS

New position

High space charge  
section minimized

ECRIS on  
rails in order  
to be able to  
open the  
extraction



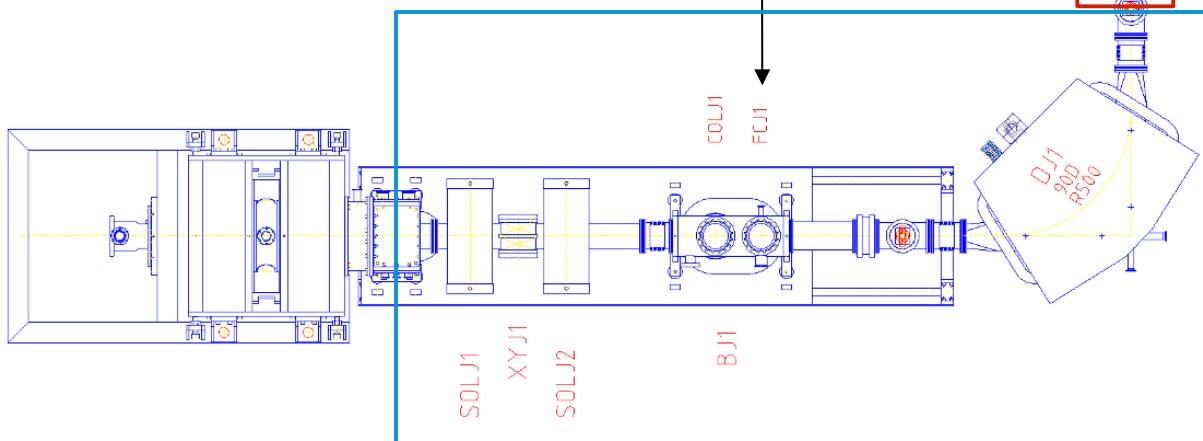
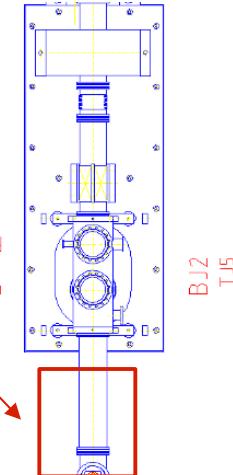
Glazer solenoid for ion  
optical fine tuning (match  
the focal point(s)). No  
beam waists between  
ECRIS and dipole

# B) HV biased beam line

Increased ECRIS extraction voltage and higher beam energy at the high space charge section

Asymmetric Einzel lens to slow down the beam

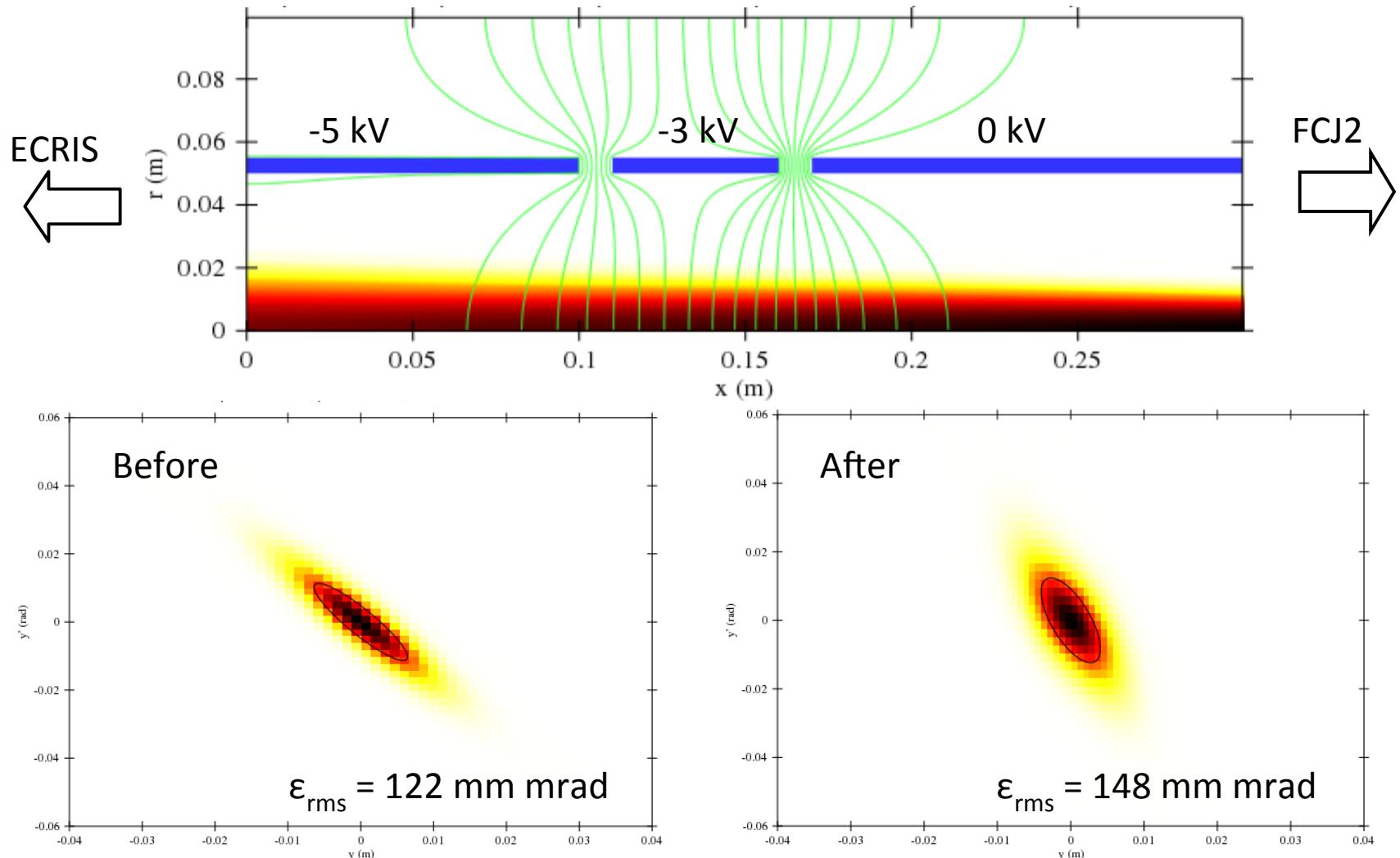
Beam focal point



High voltage beam line section (~ -5 kV)

# Slowing down the beam

Simple Einzel lens simulation



# Both upgrades

- Upgrades are cumulative
  - Both offer improvement to current situation
- Can be done in phases
  - Flexible realization
  - Downtime in shorter periods
- Proposed: first ECRIS moved, later HV biasing applied to the beam line (biasing easier to do after moving the ECRIS)

# Both upgrades

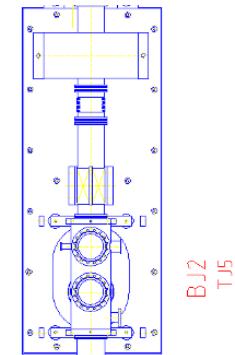
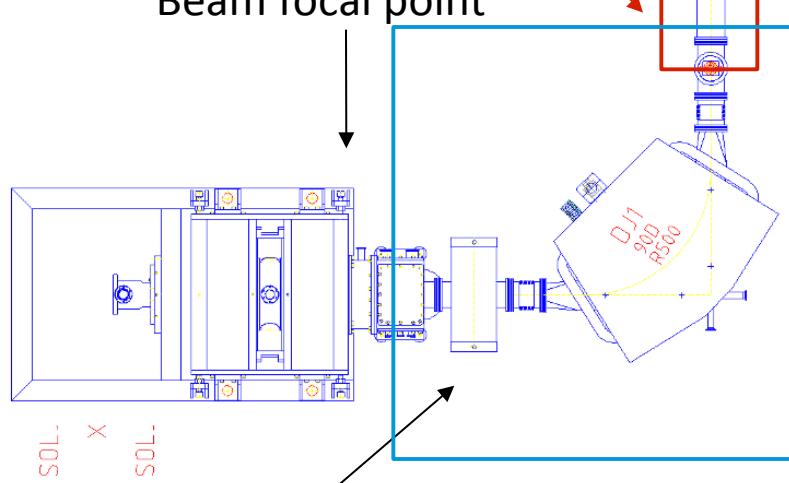
Minimization of the high space charge section and HV biased beam line

Asymmetric Einzel lens to slow down the beam

ECRIS on rails in order to be able to open the extraction

Glazer solenoid for ion optical fine tuning (match the focal point(s))

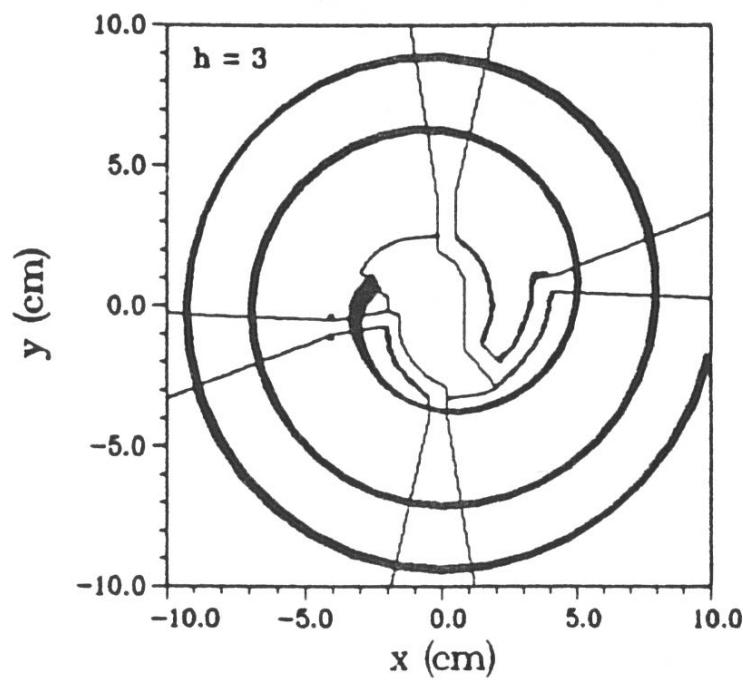
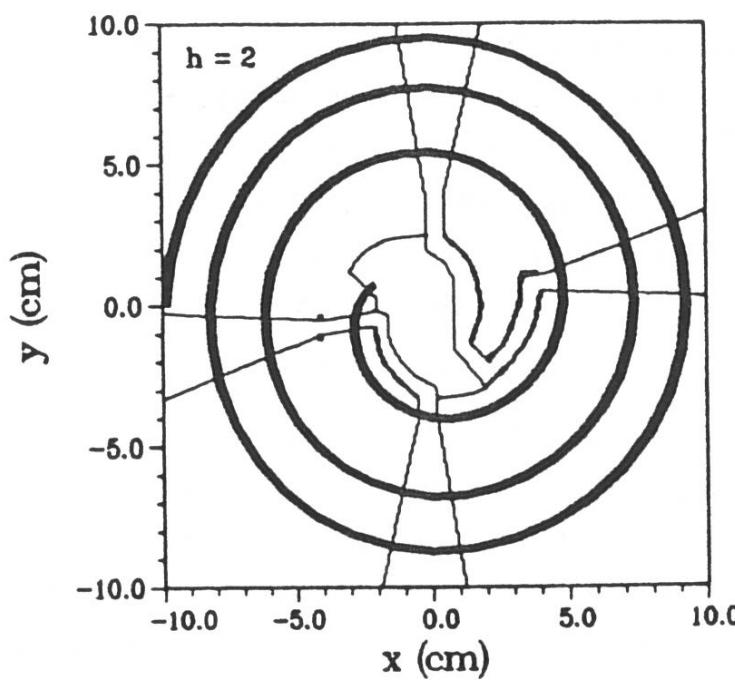
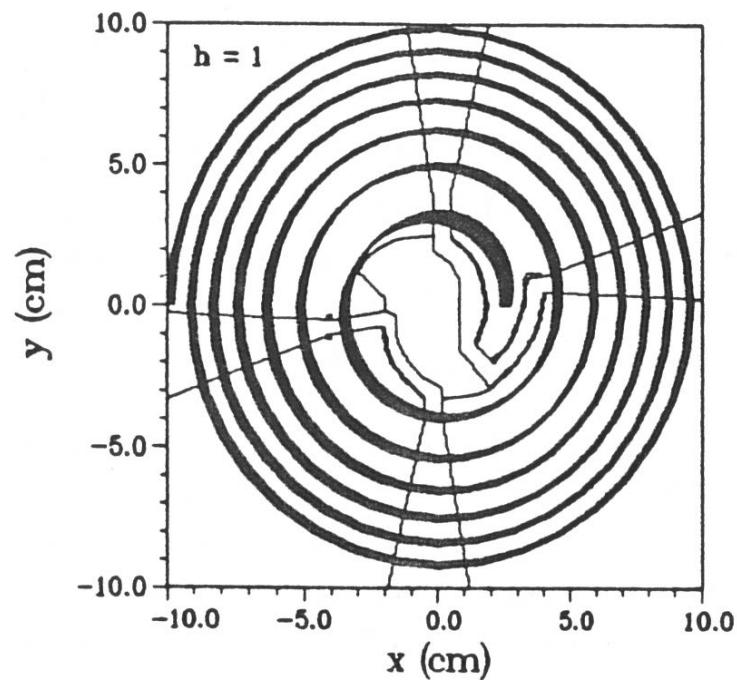
Beam focal point



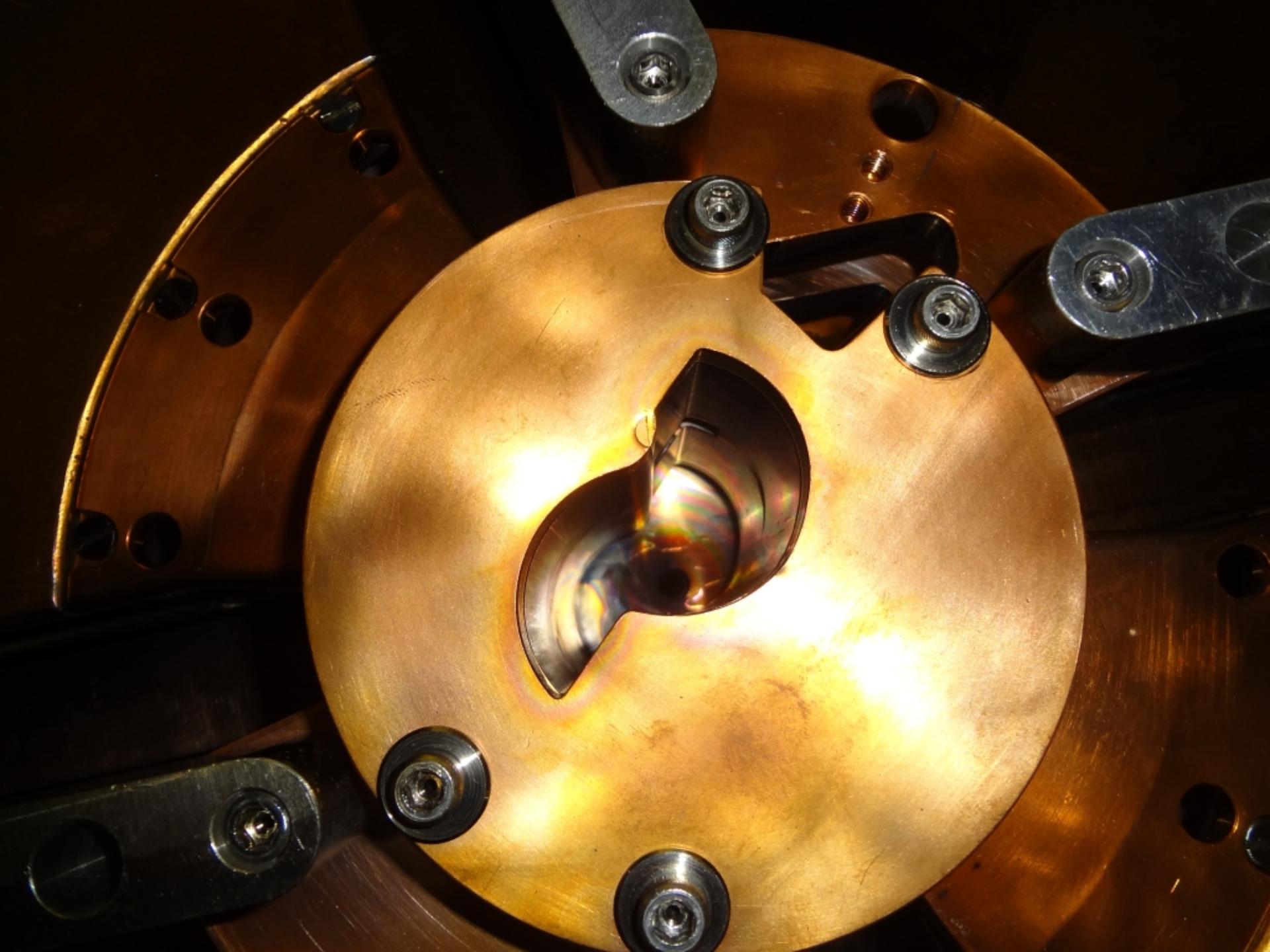
High voltage beam line section (~ -5 kV)

# One more step?

- Slowing down the beam after  $q/m$  selection does not remove the possible space charge problem in the rest of the beam line
  - However, only one  $q/m$  left and the beam current very seldom exceeds the **space charge limit** (e.g. **1.3 mA for 6 keV proton beam**)
- If the space charge is a problem, increase the injection energy
  - **New central region and inflector** in the cyclotron







# Future projects (International collaboration)

## ***MIDAS: Minimization of Destructive plasma processes in ECRIS (ENSAR JRA)***

- Coordinator: JYFL
- The focus is to increase the extracted current density of ions with mass over charge ( $M/q$ ) ratio of 3-6, e.g. charge states 21-43 in the case of xenon
  - *the intensity of highly charged ion beams can be increased substantially by minimizing the rate of charge exchange reactions*
  - *the intensities of the extracted beams can be increased by influencing the ion losses towards the extraction*

## ***Solid state RF amplifiers to replace RF-tubes***

- The availability of conventional RF-tubes is foreseen to reduce in the future
- High power solid state amplifiers already in use for fixed frequency
- Development needed for a wide frequency range (e.g. 10 – 21 MHz)
  - *One commercial manufacturer at the moment*
  - *High development costs*
    - *Divide costs by several customers*
    - *R&D as international collaboration*

